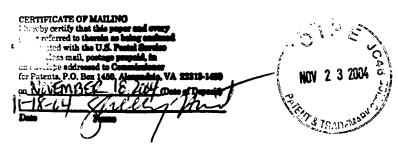
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| | TRANSMITTAL FORM | | | Application Number | 10/786,410 February 24, 2004 | | | | | | |
| TPA | | | | Filing Date | | | | | | | |
| , , , | | | | First Named Inventor | | | | | | | |
| | | | | Art Unit | | | | | | | |
| v 2 3 2004 | | | | Examiner Name | | | | | | | |
| (,,, |) | | 4 | Attorney Docket Number | 006915 P10 | | | | | | |
| FRANCIA | Total Number of | Pages in This Submission | 1 | 1 | | | | | | | |
| | ENCLOSURES (Check all that apply) | | | | | | | | | | |
| | Amendmen Af | iter Final fidavits/declaration(s) of Time Request shandonment Request on Disclosure Statement Copy of Priority | | Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addr Terminal Disclaimer Request for Refund CD, Number of CD(s) | After Allowance communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): | | | | | | |
| _ | | SIGNA | TURE C | OF APPLICANT, ATTORN | EY. OR AGENT | | | | | | |
| or Inc Sig | dividual name ignature | Robert M. Wall | | Reg. No. 29 | | | | | | | |
| | ate | 11-18-2004 | | | | | | | | | |
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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



PATENT

Attorney Docket No. 006915 P10 RW Ref. No. APM/009-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: Dan MAYDAN, et al. |)) Group Art Unit: 1763 |
|---|--------------------------|
| Entitled: FABRICATION OF SILICON-ON-INSULATOR STRUCTURE USING PLASMA IMMERSION ION IMPLANTATION |) Examiner: Unknown)) |
| Serial No.: 10/786,410 |) |
| Filing Date: February 24, 2004 |) |

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace

Registration No. 29,119 Attorney for Applicants Customer No. 000044843

Robert M. Wallace Patent Attorney 2112 Eastman Avenue, Suite 102 Ventura, CA 93003 (805) 644-4035 FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 006915 P10 Serial No.: 10/786,410

Group: 1763

Applicant(s): Dan MAYDAN, et al.

Filing Date: 02-24-2004

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LIST OF PRIOR ART CITED BY APPLICANT

(Use several sheets if necessary)

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Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).